

IFW

Docket No.: 65326-035

PATENT**-IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
Hiroyuki SHIROTA : Confirmation Number: 5722  
Serial No.: 10/814,429 : Group Art Unit: 2861  
Filed: April 01, 2004 : Examiner: Unknown  
  
For: **PATTERN WRITING APPARATUS AND PATTERN WRITING METHOD**

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop IDS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

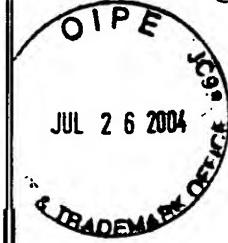
Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT WILL & EMERY LLP

  
Stephen A. Becker  
Registration No. 26,527

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
(202) 756-8000 SAB:tlg  
Facsimile: (202) 756-8087  
**Date: July 27, 2004**

<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  <b>(PTO-1449)</b>				ATTY. DOCKET NO. <b>65326-035</b>	SERIAL NO. <b>10/814,429</b>		
				<b>APPLICANT Hiroyuki SHIROTA</b>			
				FILING DATE <b>April 01, 2004</b>	GROUP <b>2861</b>		
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code <sub>2</sub> ( <i>if known</i> )	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US 5,049,901	9/17/1991	Gelbart	Correspondence to JP 6-100829		
		US 6,133,986	10/17/2000	Johnson	Correspondence to PCT(WO) 2001-500628		
		US 6,251,550 B1	6/26/2001	Ishikawa			
		US 6,473,237 B2	10/29/2002	Mei			
		US 6,493,867 B1	12/10/2002	Mei et al.			
		US 6,537,738 B1	3/25/2003	Mei et al.			
		US 5,291,329	3/1/1994	Wakimoto et al.	Correspondence to JP 2717035		
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number &-Kind Codes ( <i>if known</i> )	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP 62-021220	1/29/1987	CANON INC		w/English abstract	
		JP 2001-133893 A	5/18/2001	NORITSU KOKI CO LTD		w/English abstract	
		JP 10-112579	4/28/1998	M S TEC:KK		w/English abstract	
		JP 6-100829	12/12/1994	CREO PRODUCTS INCORPORATED		Corresponding U.S. Patent 5,049,901	
		JP 6-55776	3/1/1994	----		Corresponding EP 0 556 591	
		EP 0 556 591 A1	8/25/1993	TEXAS INSTRUMENTS INCORPORATED	Correspondence to JP 6-55776	YES	
		JP 2875125	1/14/1999	CREO PRODUCTS INCORPORATED		English translation of claims and spec.	
		PCT(WO) 2001-500628 A	1/16/2001	----		Corresponding U.S. 6,133,986	
		JP 3254248	11/22/2001	----		Corresponding EP 0 528 285	
		EP 0 528 285 A1	2/24/1993	TEXAS INSTRUMENTS INCORPORATED	Correspondence to JP 3254248	YES	
		JP 2710519	10/24/1997	----		English translation of claims and spec.	
		JP 2717035	11/7/1997	----		Corresponding U.S. 5,291,329	
		JP 06-083023	3/25/1994	MICRONIC LASER SYSTEM AB		w/English abstract	
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
<b>EXAMINER</b>				<b>DATE CONSIDERED</b>			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.  
Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.